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	र्द्य			Serial Number		10/723,332				
(MAR 0 8 2004 (20)			Filing Date			November 25, 2003				
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Group Art U				nit		2859				
	CHEZ XI VOIVILL III		Examiner Na	ame		Not yet assigned				
	FORM	Attorney Do	cket No.	7	DPL-043PR					
		Patent No.			Not applicable					
			Issue Date		7	Not applicable				
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Fee Transmittal Form			Copy of Notice	to File Missing eation (PTO-1553)		Notice of Appeal to Board of Patent Appeals and Interferences				
	☐ Check Attached☐ Copy of Fee Transmittal Form		Formal Drawin			_				
	Amendment/Response		Request For Co Examination (I Transmittal			Status Inquiry				
	☐ Preliminary ☐ After Final		Transmittai		Σ	Return Receipt Postcard				
	☐ Affidavits/declaration(s) ☐ Letter to Official ☐ Draftsperson		Power of Attor (Revocation of	ney Prior Powers)	Σ	Certificate of First Class Mailing under 37 C.F.R. 1.8				
	including Drawings [Total Sheets]		Terminal Disc	aimer		Certificate of Facsimile Transmission under 37 C.F.R. 1.8				
	Petition for Extension of Time			aration and Power Utility or Design		Additional Enclosure(s) (please identify below)				
⊠	Information Disclosure Statement		Small Entity S	tatement						
	<ul><li>✓ Form PTO-1449</li><li>✓ Copis of IDS</li><li>Citations C1-C5</li></ul>		CD(s) for large	e table or computer						
	Certified Copy of Priority Document(s)		Amendment A	fter Allowance						
	Sequence Listing submission Paper Copy/CD Computer Readable Copy Statement verifying identity of above		Request for Co Correction Certificate duplicate)	ertificate of of Correction (in						
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Direct	Testa, Hu High Stre 125 High Boston, N Tel. No.:	et Tower	nibeault, LLP	Date: March <b>Z</b> , 200 Reg. No. 54,130 Tel. No. (617) 310- Fax No. (617) 248-	-86					



**PATENT** 

Atty. Docket No.: DPL-043

(6209/53)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS:

Williams et al.

APPLICATION NO.

10/723,332

GROUP NO.

2859

FILING DATE:

November 25, 2003

**EXAMINER:** 

Not yet assigned

TITLE:

MEMs Based Thermogravimetric Analyzer

## CERTIFICATE OF FIRST CLASS MAILING UNDER 37 C.F.R. 1.8

I hereby certify that this correspondence, and any documents referred to as enclosed herein, are being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 3 day of March, 2004.

Susan Boucher

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith is/are:

Transmittal Form (1 pg.); Information Disclosure Statement (2 pgs.); PTO Form 1449 (2 pgs.); copies of cited references C1-C5; and a return-receipt postcard.

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# THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S):

Williams et al.

APPLICATION NO.

10/723,332

GROUP NO.

2859

FILING DATE:

November 25, 2003

**EXAMINER:** 

Not yet assigned

TITLE:

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

### INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with the provisions of 37 C.F.R. 1.97 and 1.98, Applicants hereby make of record the patents and publications listed on the accompanying Form PTO-1449, and other information contained herein, for consideration by the Examiner in connection with the examination of the above-identified patent application.

#### **REMARKS**

In accordance with the provisions of 37 C.F.R. 1.97, this statement is being filed (CHECK ONE):

(1)	within three (3) months of the <b>filing date</b> of a national application other than a continued prosecution application under 37 C.F.R. 1.53(d), or within three (3) months of the <b>date of entry of the national stage</b> as set forth in 37 C.F.R. 1.491 in an international application, or before the mailing of the <b>first Office action</b> on the merits, or before the mailing of a <b>first Office action</b> after the filing of a request for continued examination under 37 C.F.R. 1.114; or
(2)	after the period defined in (1) but before the mailing date of a <b>final action</b> or a <b>notice</b> of allowance under 37 C.F.R. 1.311, and
	the requisite Statement is below, OR
	the requisite fee under 37 C.F.R. 1.17(p), namely \$180.00, is included herein, or

Information Disclosure Statement Application No. 10/723,332 Page 2 of 2

(3)	after the mailing date of a final action or notice of allowance but before the payment of the issue fee, AND
	the requisite Statement is below, AND
	the requisite petition fee under 37 C.F.R. 1.17(p), namely \$180.00 is included herein.

It is respectfully requested that each of the patents and publications listed on the attached Form PTO-1449, and other information contained herein, be made of record in this application.

#### **STATEMENT**

As required under 37 C.F.R. 1.97(e), Applicant(s), through the undersigned, hereby state either that [check the appropriate space only if either (2) or (3) is checked on the previous page and the Statement is required]:

- 1. Each item of information contained in the Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application **not more than three months** prior to the filing of the Information Disclosure Statement; or
- No item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing this Statement after making reasonable inquiry, no item of information contained in the Information Disclosure Statement was known to any individual designated in 37 C.F.R. 1.56(c) more than three months prior to the filing of the Information Disclosure Statement.

Date: March 3\_\_, 2004 Reg. No. 54,130

 $\Box$ 

Tel. No.: (617) 310-8619 Fax No.: (617) 248-7100

3027446\_1.DOC

Respectfully submitted,

Edward A. Gordon

Attorney for the Applicants
Testa, Hurwitz, & Thibeault, LLP

High Street Tower 125 High Street

Boston, Massachusetts 02110

FORM PTO - REDENARY

INFORMATION DISCLOSURE STATEMENT

ATTORNEY DOCKET NO. DPL-043

APPLICANT(S): Williams et al.

APPLICATION NO. 10/723,332

FILING DATE: November 25, 2003 GROUP: 2859

## U.S. PATENT DOCUMENTS

EXAM. INIT.				CLASS SUB CLASS		FILING DATE IF APPROPRIATE					
	Al	4,783,174	11/08/88	Gmelin et al			374	33	08/18	3/86	
	A2	5,165,792	11/24/92	Crowe et al.			374	10	03/0	1/91	
-	A3	5,212,988	5/25/93	White et al.			73	599	10/10	0/91	
,	A4	5,288,147	02/22/94	Schaefer et a	al.		374	10	11/09	9/92	
	A5	5,416,322	5/16/95	Chace et al.			250	288	04/2	1/94	
	A6	5,842,788	12/01/98	Danley et al.			374	12	10/3	1/97	
	A7	6,079,873	06/27/00	Cavicchi et a	al.		374	10	06/30	)/98	
	A8	6,106,149	08/22/00	Smith			374	31	12/02	2/98	
	A9	6,189,367	02/20/01	Smith et al.			73	19.03	12/02/98		
_	A10	6,190,035	02/20/01	Smith			374	31	05/20	5/00	
	A11	6,238,085	05/29/01	Higashi et al	l.		374	10	12/3	1/98	
· <del>-</del>	A12	6,354,732	03/12/02	Casati et al.			374	14	07/1	3/00	
	A13	6,331,074	12/18/01	Kimura			374	10	01/1	5/98	
	A14	6,370,939	04/16/02	Smith et al.	<u>-</u>		73	19.03	02/1	5/01	
	A15	6,439,765	08/27/02	Smith Smith et al.			374	31 01/23/01 19.03 02/16/01		01/23/01	
·	A16	2001/0008081	07/19/01				73			5/01	
<del> </del>	A17	2001/0012312	08/09/01	Smith		374	31	01/23/01			
-	A18	2002/0003830	01/10/02	Tanaka et al.		374	31	01/12/01			
-	A19	2003/0043880	03/06/03	Meyler et al			374	32	06/2	8/02	
	A20	2003/0033876	02/20/03	Roukes et al			73	580	05/0	3/02	
			FOREI	GN PATEN	T DOCU	MENTS			-		
EXAM. INIT.		DOCUMENT NUMBER	DATE	COUNTRY CODE	CLASS	SUB CLASS	FILING DATE	ABSTR. ONLY	ACT	ENGLISH LANG (Y/N)	



FORM PTO – 1449

INFORMATION DISCLOSURE STATEMENT

ATTORNEY DOCKET NO. DPL-043

APPLICANT(S): Williams et al.

APPLICATION NO. 10/723,332

FILING DATE: November 25, 2003 GROUP: Not yet assigned

## OTHER ART, JOURNAL ARTICLES, ETC.

EXAM. INIT.	OTHER DOCUMENTS: (Including Author, Title, Date, Relevant Pages, Place of Publication)					
	Cl	RJ LEE microsytems™, NanoScale 9100™ User's Manual.				
	C2	SAW Sensor Seminar, Helsinki University of Technology (HUT), Material Physics Lab (May 2002).				
-	C3	TA Instruments "Modulated Thermogravimetric Analysis: A new approach for obtaining kinetic parameters."				
	C4	TA Instruments brochure TGA 2050 Thermogravimetric Analyzer.				
	C5	TA Instruments, "Thermogravimetric Analysis" (TGA)," slide presentation.				